Enhanced hole concentration in strain-compensated BAlN/AlGaN superlattice for deep ultraviolet light-emitting diodes

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ABSTRACT

The hole concentration in the strain-compensated B_{0.14}Al_{0.86}N/Al_{0.5}Ga_{0.5}N superlattice (SCSL) is investigated. Compared with the Al_{0.6}Ga_{0.4}N/Al_{0.5}Ga_{0.5}N SL, the effective hole concentration in the SCSL could be improved from 1.1 \times 10^{17} \text{ cm}^{-3} to 8.7 \times 10^{18} \text{ cm}^{-3} due to the remarkably enlarged valence band bending from 53 \text{ meV} to 533 \text{ meV}. We then propose the ultraviolet light-emitting diode (UV LED) structure emitting at 284 nm with the SCSL p-region. Compared with the bulk p-region structure, the UV LED with the SCSL p-region shows improved output characteristics due to the reduced electron leakage and improved hole injection ability. The internal quantum efficiency (IQE) and droop ratio of the SCSL LED structure increases from 49.5% to 54.1% and decreases from 36.8% to 13.6%, respectively. Moreover, the light output powers of the Al_{0.6}Ga_{0.4}N/Al_{0.5}Ga_{0.5}N SL structure and SCSL structure have been improved by 16.3% and 49.1% over the bulk p-region counterpart. Our results indicate that the SCSL structure can be a promising candidate for the high-performance UV LED.

1. Introduction

Effective p-type doping of AlGaN films is of great importance for deep ultraviolet light-emitting diode (DUV LED). However, the conductivity of AlGaN films is poor for that the acceptor (e.g., Mg) activation energy is extremely large in the high-Al composition AlGaN films, for example, the Mg activation energy in GaN and AlN films are 170 and 500 meV, respectively [1,2]. The generally adopted p-type AlGaN films cannot activate enough holes to combine with electrons in the active region, resulting in the increase of resistance and low radiative recombination efficiency of LED. Moreover, the AlGaN films grown on the AlN template suffer from compressive stress because of the lattice mismatch between AlN and GaN (2.5% [3]). The compressive stress could induce misfit dislocations and lead to crack generation during the epitaxy and deteriorate the output properties of LED [4,5]. To thoroughly develop the potential of light-emitting devices, the highly conductive p-type AlGaN films with less strain relaxation are highly desired.

Superlattice (SL) has been proposed to effectively improve the conductivity of p-type AlGaN films because of the spontaneous and piezoelectric field-induced energy shift of the valence band [6,7]. The Mg-doped AlN/Al_{0.75}Ga_{0.25}N SL and Al_{0.63}Ga_{0.37}N/Al_{0.51}Ga_{0.49}N SL with the hole concentration on the order of 10^{18} \text{ cm}^{-3} have been demonstrated [8,9]. Moreover, strain-compensated superlattice (SCSL), such as the p-type AlGaN/InGaN SCSL, has been proposed to improve the performance of (In)GaN-based LEDs [10,11]. Due to...
that, the lattice constant of AlGaN and InGaN are smaller and larger than that of GaN, respectively, the strain of the AlGaN/InGaN SL grown on the GaN template could be fully compensated. As a result, the crack generation could be suppressed, and the crystal quality of epitaxial films could be improved. However, this AlGaN/InGaN SCSL could not be used in the DUV LED due to the ultraviolet light absorption of the InGaN material. Besides, to compensate for the compressive stress of AlGaN films grown on the AlN template, the employment of InGaN material will be out of efficiency due to the large lattice constant.

Wurtzite BAIN alloys possess unique properties in polarization and strain modulation are promising to be used in UV LED and high electron mobility transistors (HEMTs) [12,13]. In our recent work, the band alignment of BAIN/AlGaN heterostructures has been investigated experimentally, revealing the device applications of BAIN alloys [14,15]. Moreover, the multiple-pairs $B_{0.14}Al_{0.86}N/Al_{0.7}Ga_{0.3}N$ SL structures have been demonstrated [16,17]. Furthermore, the a-lattice and c-lattice constant of $B_{0.14}Al_{0.86}N$ have been reported to be 3.027 and 4.798 Å, respectively [18]. The value of the a-lattice constant of $B_{0.14}Al_{0.86}N$ is smaller than that of AlN (3.112 Å [19]), implying that the $B_{0.14}Al_{0.86}N$ and AlGaAs films on the AlN template have also been observed by scanning transmission electron microscopy (STEM) measurements [17]. As a result, the periodically grown $B_{0.14}Al_{0.86}N$ and AlGaN films on the AlN template could effectively reduce the overall stress of the SL structure. In this study, the hole concentration enhancement at the interface of the strain-compensated $B_{0.14}Al_{0.86}N/Al_{0.5}Ga_{0.5}N$ SL is theoretically investigated. The replacement of the conventional $Al_{0.5}Ga_{0.5}N$ p-region with the $Al_{0.5}Ga_{0.5}N$ SL p-region and SCSL p-region in the UV LED structure emitting at 284 nm is also carried out. The energy band profiles, carrier distributions, and output characteristics of these LEDs are systematically presented.

2. Strain-compensated superlattice (SCSL)

The strain of an epitaxial layer grown on substrate considering the lattice constant difference is defined as equation [20], $a_{sub}$ and $a_{epi}$ are the lattice constant of the substrate and epitaxial layer, respectively. When applying the strain calculation method to design the SCSL, the thickness and lattice constant of each layer of the SL should be taken into consideration. The average a-lattice constant of the SCSL ($< a >$) is described as equation (2) [20], $t_1$, $t_2$ and $a_1$, $a_2$ are the thickness and unstrained lattice constant of each layer. For the SCSL, the average strain should be zero, meaning that the value of $< a >$ is equal to the value of $a_{sub}$.

$$
epsilon = \frac{a_{sub} - a_{epi}}{a_{epi}}$$

$$< a > = \frac{t_1a_1 + t_2a_2}{t_1 + t_2}$$

In this work, the proposed SCSL is grown on the AlN/sapphire template ($a_{sub} = 3.112$ Å [19]). The thickness of the $B_{0.14}Al_{0.86}N$ film is assumed to be 2 nm ($a_1 = 3.027$ Å [18], $t_1 = 2$ nm). To compensate for the strain of the $B_{0.14}Al_{0.86}N$ film, the thickness and composition of the AlGaN film can be modulated by the employment of Vegard’s Law. The composition of the AlGaN film is chosen to be 50%. The lattice constant of $Al_{0.5}Ga_{0.5}N$ is 3.151 Å, which is calculated by Vegard’s Law, and the calculated compensating thickness is 4 nm ($a_2 = 3.151$ Å, $t_2 = 4$ nm). As the highly p-type doping is hardly achieved in the high Al content AlGaN films, we adopt the $Al_{0.5}Ga_{0.5}N$ films ($a_2 = 3.143$ Å) with the same thickness as $B_{0.14}Al_{0.86}N$ films as a reference superlattice structure.

The number of holes at the interface of the superlattice is determined by the magnitude of the band bending ($\Delta V_b$) [21], [22]. The energy band diagrams of the $Al_{0.5}Ga_{0.5}N/Al_{0.5}Ga_{0.5}N$ SL and SCSL are shown in Fig. 1a and Fig. 1c. Due to the large polarization field of $B_{0.14}Al_{0.86}N$ material, the $\Delta V_b$ of SCSL ($\Delta V_b = 533$ meV) is distinctly larger than that of $Al_{0.5}Ga_{0.5}N/Al_{0.5}Ga_{0.5}N$ SL ($\Delta V_b = 53$ meV). Moreover, the position of the valence band of SCSL is higher than the Fermi Level (EF), indicating that the number of holes at the peak hole concentration at the interface of the $Al_{0.6}Ga_{0.4}N/Al_{0.5}Ga_{0.5}N$ SL and SCSL are around 4.0 × 10^17 cm^-3 and 1.5 × 10^20 cm^-3, respectively. Moreover, holes are more confined with less broadened peaks in the SCSL due to the large valence band difference between $B_{0.14}Al_{0.86}N$ and $Al_{0.5}Ga_{0.5}N$. The effective hole concentration in each pair of the SL is de

3. DUV LEDs with BAIN/AlGaN superlattice

The schematic diagrams of the designed UV LED structures are shown in Fig. 2. The conventional structure (LED A) is grown on an AlN/sapphire template. The 3-μm Si-doped $Al_{0.5}Ga_{0.5}N$ cladding layer (n-doping = 5 × 10^18 cm^-3) is deposited firstly. The active region is composed of five 2-nm $Al_{0.4}Ga_{0.6}N$ quantum wells (QWs) sandwiched by six 12-nm $Al_{0.5}Ga_{0.5}N$ quantum barriers (QBs). Above the last QB, the 10-nm Mg-doped $Al_{0.65}Ga_{0.35}N$ (p-doping = 2 × 10^19 cm^-3) electron-blocking layer (EBL), 24-nm Mg-doped $Al_{0.5}Ga_{0.5}N$ (p-doping = 2 × 10^19 cm^-3) hole injection layer and 10-nm Mg-doped GaN (p-doping = 1 × 10^20 cm^-3) cap layer are deposited sequentially. In this study, we employ two kinds of superlattice hole injection layers. For the LED B, the hole injection layer is replaced by the 4-pairs 2-nm $Al_{0.5}Ga_{0.5}N/4$-nm $Al_{0.5}Ga_{0.5}N$ SLs, while the 4-pairs 2-nm $B_{0.14}Al_{0.86}N/4$-nm $Al_{0.5}Ga_{0.5}N$ SCSL is adopted in the LED.
C. The total thickness and Mg doping concentration of these hole injection layers in the three LEDs are kept equal. Other layers of LED B and C are kept the same as LED A.

The simulation software used in this study is the Advanced Physical Models of Semiconductor Devices (APSYS) program. The band offset ratio of AlGaN materials is set to be 0.7/0.3 [23]. The bandgap of AlGaN film is calculated by formula (3), with a bowing parameter $b$ of 0.94 [24]. The polarization constants (including spontaneous polarization (SP) and piezoelectric (PZ) constants) of AlGaN materials can be found in Ref. [25]. The mobility and effective mass of carriers in the AlGaN materials are the generally accepted values from the experimental results [23]. The acceptor activation energy of the AlGaN films increases linearly with the Al composition [1, 2]. The bandgap of $B_{0.14}Al_{0.86}N$ is set to be 5.7 eV, which is calculated by first-principles calculation based on density functional

Fig. 1. (a) Energy band diagram of $Al_{0.6}Ga_{0.4}N/Al_{0.5}Ga_{0.5}N$ SLs, (b) hole concentration of $Al_{0.6}Ga_{0.4}N/Al_{0.5}Ga_{0.5}N$ SLs, (c) energy band diagram of $B_{0.14}Al_{0.86}N/Al_{0.5}Ga_{0.5}N$ SLs, and (d) hole concentration of $B_{0.14}Al_{0.86}N/Al_{0.5}Ga_{0.5}N$ SLs at equilibrium. All the parameters including the doping concentration, acceptor activation energy, and polarization screening factor are the same as the LED structures in the part of DUV LEDs with BAIN/AlGaN superlattice.

Fig. 2. Schematic diagrams of UV LEDs with different p-type layers. LED A is the conventional structure with a p-type $Al_{0.5}Ga_{0.5}N$ layer. LED B has the p-type $Al_{0.6}Ga_{0.4}N/Al_{0.5}Ga_{0.5}N$ SLs and LED C has the strain-compensated p-type $B_{0.14}Al_{0.86}N/Al_{0.5}Ga_{0.5}N$ SLs.

C. The total thickness and Mg doping concentration of these hole injection layers in the three LEDs are kept equal. Other layers of LED B and C are kept the same as LED A.

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Fig. 3. Energy band diagrams of (a) LED A, (b) LED B, and (c) LED C at 75 mA.
The electron concentration, hole concentration, and radiative recombination rate in the active region of these LED structures at 75 mA are shown in Fig. 5. The highest electron and hole concentration, as well as radiative recombination rate are obtained in LED C. On the other hand, LED B and C have larger effective barrier heights of electron (\(\Phi_e\)) and hole (\(\Phi_h\)) calculated. The values of \(\Phi_e\) for LED A, B, and C are 463, 431, and 897 meV, respectively. The large \(\Phi_e\) value of LED C is attributed to the large bandgap of BAIN material and the band alignment of BAIN/GaN, which has also been reported in our previous work [12]. The larger \(\Phi_e\) of LED B and C implies that the suppression of electron overflow could be improved by the employment of the SL structure, especially the SCSL structure. The values of \(\Phi_h\) for LED A, B, and C are 357, 353, and 355 meV, respectively. The slightly reduced \(\Phi_h\) could be favorable for the hole injection from the p-region to the active region. In terms of these values of \(\Phi_e\) and \(\Phi_h\), it could be found that the SCSL p-region has a great effect on the \(\Phi_e\) but the inconspicuous impact on the \(\Phi_h\) compared with the bulk Al0.5Ga0.5N or Al0.5Ga0.4N/Al0.5Ga0.5N SL p-region.

The electron current density (ECD) and hole current density (HCD) of these LED structures at 75 mA are shown in Fig. 4. The ECD in the p-region of LED A, B, and C are 46.3, 31.5, and 997 meV, respectively. The much lower ECD in the p-region of LED C indicates that the electron leakage of LED C is the lowest. The reason for the superiority of LED C in hindering electron overflow could be attributed to the higher effective barrier height of electrons in the SCSL structures. The less electron leakage will be beneficial for the reduction of nonradiative recombination in the p-region. The HCD in the p-region of LED A, B, and C are 78.7, 93.5, and 125.0 A/cm², respectively. The hole injection ability of LED C is the best among these LED structures. The enhanced hole injection efficiency of LED C could be explained by the fact that the supplied holes from the p-region could be greatly promoted by the employment of the SCSL structure.

The electron concentration, hole concentration, and radiative recombination rate in the active region of these LED structures at 75 mA are shown in Fig. 5. The highest electron and hole concentration, as well as radiative recombination rate are obtained in LED C. On the one hand, LED B and C have larger effective barrier heights of electron (as shown in Fig. 3), which could effectively block the electron overflow to the p-region. Thus, the electron concentrations in the active region of LED B and C are higher than LED A. On the other hand, the SL hole injection layer of LED B and C could activate more holes than LED A, especially the SCSL (as shown in Fig. 1). Therefore, the hole concentration in the active regions of LED B and C could also be improved even though the effective barrier height of hole is comparable in these LED structures. The peak radiative recombination rate of LED C and LED B are 5.0 \(\times\) 10²⁶ and 4.0 \(\times\) 10²⁶ cm⁻³/s, which are 1.5 and 1.2 times that of LED A (3.4 \(\times\) 10²⁶ cm⁻³/s), respectively. The enhancement of the radiative recombination rate of LED B and C could be attributed to the improvement of electron and hole concentrations in the active region.

The internal quantum efficiency (IQE), output power, I–V characteristics, and wall-plug efficiency (WPE) of these LED structures at the current of 75 mA are shown in Fig. 6. For the LED C, the peak efficiency can be achieved to be 54.1%, while those values of LED A and LED B are 49.5% and 50.4%. The droop ratio of LED C is 13.6%, which is much lower than those values of LED A (36.8%) and LED B (27.6%). One reason is that the higher electron barrier height of LED C blocks electron overflow to p-region, as shown in Fig. 3. The resultant lower electron current leakage will lead to a higher current at 75 mA, and less droop. When comparing LED A and LED B, the efficiency drop of LED B is still lower than LED A, although they have similar effective electron and hole barrier heights. This is because

\[
E_e(Al_{0.5}Ga_{0.5}N) = xE_e(AlN) + (1-x)E_e(GaN) - bh(1-x)
\]
Fig. 5. (a) Electron concentration, (b) hole concentration, and (c) radiative recombination rate of LED A, B, and C at 75 mA. For better comparison, the position of the green and red lines are right-shifted by 2 nm and 4 nm, respectively.
Fig. 6. (a) IQE, and (b) output power and I–V characteristics of LED A, B, and C at 75 mA.
Fig. 7. The spontaneous emission spectrum of (a) LED A, (b) LED B, and (c) LED C at 15, 30, 45, 60, 75 mA.
the more holes activated by the superlattice p-region, which is verified by the hole concentration in the QWs, as shown in Fig. 5. In this aspect, the effective hole concentration in the BAIN/AlGaN SCSL (8.7 \times 10^{18} \text{cm}^{-3}) is almost two orders of magnitude greater than that of AlGaN/AlGaN SL (1.1 \times 10^{17} \text{cm}^{-3}), as shown in Fig. 1. Thus, the droop ratio of LED C is remarkably reduced compared with LED A and LED B.

The output power of LED A, B, and C are 34.4 mW, 40.0 mW, and 51.3 mW, respectively. Compared with LED A, the output power of LED B and C has been improved by 16.3% and 49.1%. The output power enhancement of LED C could be attributed to the greatly reduced electron leakage and improved hole injection by using the SCSL. The I–V characteristics of LED A and LED B are almost the same, indicating the Al0.6Ga0.4N/Al0.5Ga0.5N superlattice p-region has less effect on the I–V characteristics of LED due to the similar conduction and valence band edge profiles of Al0.6Ga0.4N and Al0.5Ga0.5N, as shown in Fig. 3a and b. However, LED C shows a larger turn-on voltage (5.84 V), which is defined as the intersection of voltage and the slope of the linear part of the I–V curve, than the values of the LED A (4.32 V) and LED B (4.34 V). It is due to the quite large \( \Phi_e \) in LED C, which seriously hinders the flow of electrons, as shown in Fig. 3c.

The WPE, which is defined as the ratio of output power to the input electrical power, as shown in Fig. 6c. LED B has the highest WPE, while LED C shows the lowest value. It is because LED C shows the highest turn-on voltage, as shown in Fig. 6b. However, when the LED works at high injection current, the WPE shows less difference. It means the energy consumption will not so severe at this circumstance. One way to improve the WPE of LED C is to reduce the pairs of superlattice, but it will weaken the superiority of superlattice in hole generation and blocking electrons. The coordination of the work efficiency and energy consumption should be taken into consideration in the future. Although the WPE of LED C is worse than LED A and LED B, it is still worth noticing that the efficiency, output power, and radiative recombination rate of LED C are the best among these LED structures. Moreover, the BAIN/AlGaN SL is a strain compensated structure, which will be beneficial for the future epitaxy demonstration, such as crack-free. Furthermore, the BAIN material is also the first and only choice to design the strain-compensated superlattice for deep UV LEDs.

The spontaneous emission spectrums of these LED structures are shown in Fig. 7. Single peaks with the emission peak wavelength of 284 nm are observed in these structures, indicating that our SCSLs structure has a negligible effect on the emission wavelength. LED C shows the highest spontaneous emission rate due to the highest radiative recombination rate in the active region, as shown in Fig. 5c. These results mean that the emission property of UV LEDs can be remarkably improved by using the SCSL structure.

4. Conclusion

We have built the BAIN based SCSL structure and analyzed the mechanism of hole concentration enhancement in the SCSL. Because of the large valence band bending, the achieved effective hole concentration in the SCSL can be as high as 8.7 \times 10^{18} \text{cm}^{-3}. We then design three UV LED structures with different p-regions, which are bulk Al0.5Ga0.5N, Al0.6Ga0.4N/Al0.5Ga0.5N SL, and SCSL, respectively. It can be observed that the effective barrier height of the electron increases by using the SL structure, and even more apparent in the SCSL. This phenomenon could be one reason for the reduced electron leakage in the LED structure with the SCSL p-region. Although the effective barrier height of the hole is comparable among these structures, the hole injection ability of the LED structure with SCSL p-region still increases remarkably on account of the more activated holes in the SCSL p-region. Therefore, the carrier concentrations and radiative recombination rate in the active region of the UV LED with SCSL p-region are increased compared with the reference structures. The efficiency droop ratio of the UV LED with SCSL p-region is significantly reduced from 36.8% (bulk p-region structure) to 13.6% (SCSL p-region structure). The output power of the UV LED with SCSL p-region can reach 51.3 mW. This structure provides a new view to design the high-performance UV LED.

Credit author statement

Wen Gu: Writing – original draft, Conceptualization, Methodology, Data curation, Formal analysis, Investigation. Yi Lu: Investigation, Writing – review & editing. Che-Hao Liao: Investigation, Writing – review & editing. Jianchang Yan: Supervision, Resources, Funding acquisition, Validation, Investigation. Junxi Wang: Investigation, Supervision, Funding acquisition. Jinmin Li: Supervision, Validation, Formal analysis, Investigation, Data curation. Xiaohang Li: Supervision, Resources, Funding acquisition, Validation, Formal analysis, Investigation, Data curation.

Declaration of competing interest

On behalf of all authors, the corresponding author states that there is no conflict of interest.

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